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Bib Data Sheet

CONFIRMATION NO. 2926

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|--|---|----------------------------------|---|--------------------------------------|--------------------------------|
| SERIAL NUMBER 10/088,306 | FILING DATE 03/18/2002 RULE | CLASS 034 | GROUP ART UNIT 3749 | ATTORNEY DOCKET NO. Q60716 | |
| APPLICANTS Hiromoto Ohno, Kanagawa, JAPAN; Toshio Ohi, Kanagawa, JAPAN; Shuji Yoshida, Kanagawa, JAPAN; Manabu Ohhira, Kanagawa, JAPAN; Koutarou Tanaka, Kanagawa, JAPAN; | | | | | |
| ** CONTINUING DATA ***** THIS APPLICATION IS A 371 OF PCT/JP01/06164 07/17/2001 WHICH CLAIMS BENEFIT OF 60/230,811 09/07/2000 * AND CLAIMS BENEFIT OF 60/261,265 01/16/2001 * (*)Data provided by applicant is not consistent with PTO records. | | | | | |
| ** FOREIGN APPLICATIONS ***** JAPAN 2000-217610 07/18/2000 JAPAN 2000-397269 12/27/2000 JAPAN 2001-189388 06/22/2001 | | | | | |
| Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after met Allowance Verified and Acknowledged | | STATE OR COUNTRY JAPAN | SHEETS DRAWING 1 | TOTAL CLAIMS 36 | INDEPENDENT CLAIMS 4 |
| ADDRESS 23373 | | | | | |
| TITLE Cleaning gas for semiconductor production equipment | | | | | |
| FILING FEE RECEIVED 1262 | FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following: | | <input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit | | |